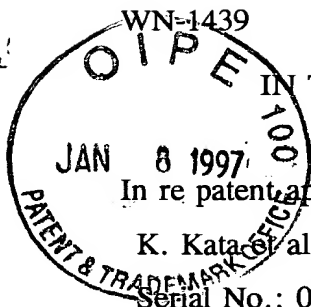


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V. H. J.



WN-1439

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

K. Katacel et al.

Serial No.: 08/533,207

Group Art Unit: 2503

Filed: September 25, 1995

Examiner: Unknown

For: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND SEMICONDUCTOR WAFER

Commissioner of Patents and Trademarks
Washington, D.C. 20231

RECEIVED

JAN 09 1997

GROUP 2500

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 C.F.R. 1.97 through 1.99 and pursuant to applicant's duty of disclosure under 37 C.F.R. 1.56, applicant respectfully brings the following documents, cited in the European Search Report and listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. Copies of the listed documents are provided herewith for the convenience of the Examiner.

This citation does not constitute an admission that the references are relevant or material to the claims. They are only cited as constituting related art of which the applicant is aware.

I hereby certify that each item of information contained in this Information Disclosure Statement was cited in a communication received from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

It is respectfully requested that the listed references be considered by the Examiner and formally made of record in this application.

WN-1439

Please charge any deficiencies in fees and credit any overpayment of fees to
Attorney's Deposit Account No. 23-1951.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Sean M. McGinn". The signature is fluid and cursive, with the first name "Sean" being more prominent.

Sean M. McGinn
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